



COPY OF PAPERS
ORIGINALLY FILED

2841
#5
Analog.5683

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Brosnihan et al.

GROUP:

2841

SERIAL NO: 09/921,456

EXAMINER:

Unknown

FILED: 08/03/01

FOR: BONDED WAFER OPTICAL MEMS PROCESS

Assistant Commissioner of Patents
Washington, D.C. 20231

Sir:

INFORMATION DISCLOSURE STATEMENT

In compliance with 37 C.F.R. §§1.56, 1.97, and 1.98, Applicant submits copies of the documents listed on the attached Form PTO-1449.

The listed documents were recently cited in a corresponding PCT application, and a copy of the International Search Report is being submitted herewith for purposes of convenience.

The Commissioner is authorized to charge Deposit Order Account No. 19-0079 for any further fee that is required.

Respectfully submitted,

Matthew E. Connors
Registration No. 33,298
Samuels, Gauthier & Stevens, LLP
225 Franklin Street, Suite 3300
Boston, Massachusetts 02110
Telephone: (617) 426-9180
Extension: 112

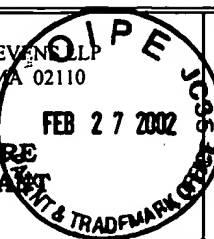
I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents and Trademarks, Washington, D.C. 20231.

Emily C. Porell
07/13/02
Date

FORM PTO-1449 SAMUELS, GAUTHIER & STEVENSON LLP
(Rev. 5/92) 225 Franklin Street, Boston, MA 02110
Telephone: (617) 426-9180

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

FEB 27 2002



Analog.5683
ATTORNEY DOCKET NO.

Brosnihan et al.
APPLICANT

08/03/01
FILING DATE

**COPY OF PAPERS
ORIGINALLY FILED**

09/921,456
SERIAL NO

2841
GROUP

Unknown
EXAMINER

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	5,216,490	06/01/1993	Greiff et al.			08/03/1990
	AB	6,021,675	02/08/2000	Seefeldt et al.			02/28/1997
	AC	5,343,064	08/30/1994	Spangler et al.			03/18/1988
	AD						
	AE						
	AF						
	AG						
	AH						

RECEIVED

MAR 06 2002

TECH CENTER 2800

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
	AI	198 47 455 A1	04/27/2000	DE			NO
	AJ	0 834 759 A2	08/04/1998	EPO			YES
	AK						
	AL						
	AM						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER INITIAL		
	AN	"Embedded Interconnect and Electrical Isolation for High-Aspect-Ratio, SOI Inertial Instruments," Brosnihan et al.; 1997. University of California, Berkeley Sensor & Actuator Center.
	AO	
	AP	

EXAMINER

DATE CONSIDERED

EXAMINER:

Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.